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BIB DATA SHEET

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10/580,107	SERIAL NUM	IBER FILING or DATE			CLASS		GROUP ART UNIT			ATTORNEY DOCKET NO.		
APPLICANTS Kenji Yakushiji, Chiba, JAPAN; Katsuki Kusunoki, Chiba, JAPAN; Hisayuki Miki, Chiba, JAPAN; ***CONTINUING DATA **********************************	10/580,10					438	2892					
Kenji Yakushiji, Chiba, JAPAN; Katsuki Kusunoki, Chiba, JAPAN; Hisayuki Miki, Chiba, JAPAN; ***CONTINUING DATA***********************************			RUL	E								
*** FOREIGN APPLICATIONS ************************************	Kenji Yakushiji, Chiba, JAPAN; Katsuki Kusunoki, Chiba, JAPAN; Hisayuki Miki, Chiba, JAPAN; ** CONTINUING DATA **********************************											
FILING FEE RECEIVED 1300 Foreign Priority claimed Yes No 35 USC 119(a-d) conditions met Yes No Verified and Acknowledged Examiner's Signature N.W. SUITE 800 WASHINGTON, DC 20037 UNITED STATES FILING FEE RECEIVED 1300 The state of the st	** FOREIGN APPLICATIONS ************************************											
ADDRESS SUGHRUE MION, PLLC 2100 PENNSYLVANIA AVENUE, N.W. SUITE 800 WASHINGTON, DC 20037 UNITED STATES TITLE Production method for semiconductor device FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following: FILING FEE RECEIVED 1300 That after Allowance HP initials Read and Acknowledged (HDAI VPHAM)	** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 03/20/2007											
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